

<b>Notice of References Cited</b>		Application/Control No. 10/567,883	Applicant(s)/Patent Under Reexamination STEIN ET AL.	
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*	B	US-2003/0231683	12-2003	Chua et al.	372/46
*	C	US-2004/0211968	10-2004	Lin et al.	257/081
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#### NON-PATENT DOCUMENTS

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